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By:  / Ruth Montalvo Date: 12/22/05

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney's Docket No.: JG-SU-5223/500577.

U.S. Application No.:

International Application No.: PCT/JP2005/000882

International Filing Date: JANUARY 25, 2005

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30 JANUARY 2004

Title of Invention:

SILICON SINGLE CRYSTAL PULLING METHOD

Applicant(s) for (DO/EO/US):

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PRELIMINARY AMENDMENT

Sir:

The above-identified application is filed concurrently herewith, please amend the specification as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the Abstract begin on page 3 of this paper.

Remarks / Arguments begin on page 4 of this paper.